IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	SHIMBORI et al.	Docket No.: 372106-105 (338531)
Serial No.	10/628,919	Art Unit: 1756
Filed:	July 29, 2003	Examiner: Young, Christopher G.
Title:	PHOTORESIST PATTERN AND FORMING METHOD THEREOF	

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Total Pages Faxed: 4

TRANSMITTAL FOR RESPONSE PURSUANT
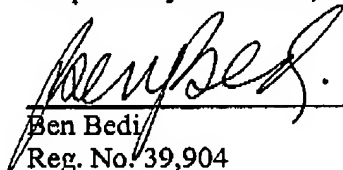## TO A REQUEST UNDER 37 CFR 1.142

Enclosed herewith for filing in the above-identified patent application:

☑ 3 Page Response Pursuant to a Request Under 37 CFR §1.142 (Restriction Requirement).

The Commissioner is authorized to charge Deposit Account No. 50-2778 for any fee deficiency or to credit any overpayment.

Respectfully submitted,

Date: February 28, 2006

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RESPONSE PURSUANT TO A REQUEST UNDER 37 CFR 1.142

Dear Sir:

In response to the Office Action mailed February 3, 2006, in which Applicants claims have been subjected to a restriction requirement, Applicants submit the following elections, amendments and remarks.

Amendments to the claims begin on page 2 of this paper.

Remarks/Arguments begin on page 3 of this paper.